

Docket No.: 1592-0155PUS1
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Masashi NAKAMURA et al.

Application No.: 10/534,695

Confirmation No.: 8694

Filed: May 13, 2005

Art Unit: 2813

For: EPITAXIAL GROWTH METHOD AND
SUBSTRATE FOR EPITAXIAL GROWTH

Examiner: M. D. Harrison

AMENDMENT AFTER FINAL ACTION UNDER 37 C.F.R. 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated April 30, 2007, finally rejecting claims 10-27, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.